



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of : Confirmation No. 1853
Shoriki NARITA et al. : Docket No. 2001-1876A
Serial No. 10/019,700 : Group Art Unit 2825
Filed January 2, 2002 : Examiner Igwe U. Anya

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BUMP FORMING APPARATUS FOR :
CHARGE APPEARANCE SEMICONDUCTOR
SUBSTRATE, CHARGE REMOVAL METHOD
FOR CHARGE APPEARANCE SEMICONDUCTOR
SUBSTRATE, CHARGE REMOVING UNIT FOR
CHARGE APPEARANCE SEMICONDUCTOR
SUBSTRATE, AND CHARGE APPEARANCE
SEMICONDUCTOR SUBSTRATE

THE COMMISSIONER IS AUTHORIZED
TO CHARGE ANY DEFICIENCY IN THE
FEES FOR THIS PAPER TO DEPOSIT
ACCOUNT NO. 23-0975

SUBMISSION OF FORMAL DRAWINGS

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

Submitted herewith are revised new A4P formal drawings, including new Fig. 40. The new drawings have been prepared to correct formal matters as discussed in the Remarks filed with the attached Amendment.

Kindly substitute the attached formal drawings for that of record.

Respectfully submitted,

Shoriki NARITA et al.

By: 

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